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|---|-------|-----------------------------------|--------------|---------------------------------------|------------------------|-----------------------|--|-----|-------------|
| APPLICANTS | | | | | | | | | |
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| ** CONTINUING DATA ********************************** | | | | | | | | | |
| ** FOREIGN APPLICATIONS ************************************ | | | | | | | | | |
| Foreign Priority claimed | | yes no | | STATE OR | SHEETS | | тот | AL. | INDEPENDENT |
| 35 USC 119 (a-d) condi met Verified and Acknowledged | | Allowande Initials | | COUNTRY JAPAN | DRAWING 6 | | CLAII 12 | | CLAIMS 3 |
| ADDRESS 22850 OBLON, SPIVAK, MCCLELLAND, MAIER & NEUSTADT, P.C. 1940 DUKE STREET ALEXANDRIA , VA 22314 | | | | | | | | | |
| TITLE Cvd method and device for forming silicon-containing insulation film | | | | | | | | | |
| | | | | ···· · | ☐ All Fees | | | | |
| FILING FEE | FEES: | Authority has been gi | ven in Pa | aper | | 1.16 Fees (Filing) | | | |
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